Process Gas Diaphragm Valve

AZ Series

Cleaned for high purity semiconductor applications. (RoHS)

SL

ΑZ

AK

BP

Cleanroom assembled and He leaked tested.

Valve meets dimensional requirements of

SEMI F36-0299, Option I.



Air Operated Type Series **AZ3542** and 4542

- Compact and lightweight by making the actuator shorter
- M5 actuation port

Manually Operated 1 Series AZ3652 and 4652

Compact and lightweight by modifying the knob design

The knob is a unique design that combines a scalloped round knob with a raised rectangular section to provide two choices of gripping.

Actuation is 90 degrees open to closed with a cutout window, on both sides of raised rectangular section, providing visual status of open or closed state.

Direction of a raised rectangular section indicate open/close status







Air operated type AZ3542/AZ4542 Series



Manually operated type AZ3652/AZ4652 Series



Body material

316L SS Electropolish and passivation internals

SEMI standard

Mounting hole, dimension, and face to face dimension are interchangeable (Guide for Dimensions and Connections of Gas Distribution Components).

User-friendly forged body

Rounded corner for safety and easy operation (forged body is for machined type.)

Port

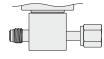


Multiple port available in various configurations

	Macl	nined	Welded			
Body						
Connection	Face seal fitting (Male)	Tube weld (Tube stub)	Face seal fitting (Male)	Face seal fitting (Female)	Tube weld (Tube stub)	
Connection size (inch)	1/4, 3/8	1/4, 3/8, 1/2	1/4, 3/8			
Interchangeability	No			Yes		

Welded type, inlet and outlet available with any combination of fitting type and size.

Further information>>> How to order P.804, 806 Example) Face seal fitting



Face seal fitting (Female) 3/8

Welded type, ports (2, 3, 4 ports) and porting configuration (flow direction 2, 3, 4) selectable

Further information>>> Optional porting configuration P.808

Air operated type

(Male) 1/4

	Series Status	Status	Body material	Max. operating	Cv * 1)	Connections	Page		
	Series	Status	Body material	pressure (MPa)	CV ·/	Fitting	rage		
	AZ3542	N.C.	2161.00	0.0	0.29	Face seal fitting	D 904		
Machined type Welded type	AZ4542	N.C.	316L SS	3101 55	3101 33	0.9	0.5 Tube we	Tube weld	P.804

Manually operated type

	Series Knob	Max. operat	Max. operating	ax. operating Cv * 1)	Connections	Dogo	
	Series	KIIOD	Body material	pressure (MPa)	CV · 1/	Fitting	Page
	AZ3652	Knob with a raised		1.7	0.29	Face seal fitting	P.806
Machined type Welded type	AZ4652	section on top 316L SS (indication window)		1.7	0.5	Tube weld	P.800

^{* 1)} Cv calculation based on SEMI Standard



Precautions for selection -

The proper regulator and valve selection can be significantly affected by parameters such as system design, flow duration, frequency of use, ambient conditions and outlet pressure. It is important to understand that one may follow this guide's recommendation, yet have a failure due to a parameter specific to the given application, as noted.

Applicable Fluid

Process Gas	Molecular Formula
Boron11 Trifluoride	11BF₃
Argon	Ar
Arsine	AsH₃
Boron Trichloride	BCl ₃
Boron Trifluoride	BF ₃
Halocarbon114	C ₂ CIF ₄
Halocarbon115	C ₂ CIF ₅
Halocarbon116	C ₂ F ₆
Acetylene	C ₂ H ₂
Halocarbon134A	C ₂ H ₂ F ₄
Ethylene	C ₂ H ₄
Halocarbon125	C ₂ HF ₅
Dimethylsilane	C ₂ SiH ₈
HalocarbonR218	C ₃ F ₈
Propene	C ₃ H ₆
Propane	СзН8
Perfluoro-butadiene	C ₄ F ₆
HalocarbonC318	C ₄ F ₈
Butene-1	C ₄ H ₈
Octafluorocyclopentene	C ₅ F ₈
Halocarbon12B2	CBr ₂ F ₂
Halocarbon13B1	CBrF₃
Halocarbon12	CCl ₂ F ₂
Halocarbon13	CCIF ₃
Halocarbon14	CF ₄
Halocarbon32	CH ₂ F ₂
Trimethylsilane	(CH₃) ₃SiH
Methyl Chloride	CH₃CI
Methyl Fluoride	CH₃F
Methanol	CH₃OH
Methylsilane	CH ₃ SiH ₃
Methane	CH ₄
Halocarbon21	CHCl₂F
Halocarbon23	CHF ₃

Chlorine Cl₂ Chlorine Trifluoride CIF₃ Carbon Monoxide CO Carbon Dioxide CO₂ Germane GeH₄ Hydrogen H₂ Hydrogen Sulfide H₂Se Hydrogen Selenide H₂Se Hydrogen Bromide HBr Hydrogen Chloride HCI Helium He Hydrogen Fluoride HF Krypton Kr Nitrogen N₂ Nitrogen Oxide N₂O Neon Ne Nitrogen Trifluoride NF₃ Ammonia NH₃ Nitric Oxide NO Oxygen O₂ Phosphorous Pentafluoride PF₅ Phosphine PH₃ Sulfer Tetrafluoride SF₄ Sulfer Hexafluoride SiF₄ Silicon Tetrachloride SiF₄ Silicon Tetrafluoride SiF₄ Dichlorosilane SiHCl₃ Silne SiHCl₃ Bilne <t< th=""><th></th><th></th></t<>		
Chlorine Trifluoride CIF3 Carbon Monoxide CO Carbon Dioxide CO2 Germane GeH4 Hydrogen H2 Hydrogen Sulfide H2S Hydrogen Selenide H2Se Hydrogen Bromide HBr Hydrogen Chloride HCI Helium He Hydrogen Fluoride HF Krypton Kr Nitrogen N2 Nitrogen Oxide Na2O Neon Ne Nitrogen Trifluoride NF3 Ammonia NH3 Nitric Oxide NO Oxygen O2 Phosphorous Pentafluoride PF5 Phosphine PH3 Sulfer Tetrafluoride SF4 Sulfer Hexafluoride SF6 Silicon Tetrachloride SiF4 Silicon Tetrafluoride SiF4 Dichlorosilane SiH2Cl2 Silane SiHCl3 Sulfur Dioxide SO2 Diethyltellurid	Process Gas	Molecular Formula
Carbon Monoxide Carbon Dioxide Carbon Dioxide Co2 Germane GeH4 Hydrogen H2 Hydrogen Sulfide Hydrogen Selenide Hydrogen Bromide HHBr Hydrogen Chloride HHCI Helium He Hydrogen Fluoride HF Krypton Kr Nitrogen Nıtrogen Oxide Neon Ne Nitrogen Trifluoride NH3 Ammonia NH3 Nitric Oxide Oxygen Phosphorous Pentafluoride PF5 Phosphine PH3 Sulfer Tetrafluoride Silcon Tetrachloride Silcon Tetrafluoride Silcon Tetrafluoride Silcon Silcol Silcon S	Chlorine	Cl ₂
Carbon Dioxide Germane GeH4 Hydrogen Hydrogen Sulfide Hydrogen Selenide Hydrogen Bromide HHBr Hydrogen Chloride HHCI Helium He Hydrogen Fluoride HF Krypton Kr Nitrogen Nitrogen Oxide Neon Neon Nitrogen Trifluoride Nitric Oxide No Oxygen Oxygen Oxygen Phosphorous Pentafluoride Sulfer Tetrafluoride Silicon Tetrachloride Silicon Tetrafluoride Silicon Silicon Silicol	Chlorine Trifluoride	CIF ₃
Germane GeH4 Hydrogen H2 Hydrogen Sulfide H2S Hydrogen Selenide H2Se Hydrogen Bromide HBr Hydrogen Chloride HCI Helium He Hydrogen Fluoride HF Krypton Kr Nitrogen N2 Nitrogen Oxide N2O Neon Ne Nitrogen Trifluoride NF3 Ammonia NH3 Nitric Oxide NO Oxygen O2 Phosphorous Pentafluoride PF5 Phosphine PH3 Sulfer Tetrafluoride SF4 Sulfer Hexafluoride Sicl4 Silicon Tetrafluoride SiCl4 Silicon Tetrafluoride SiH4 Trichlorosilane SiH4 Trichlorosilane SiHCl3 Sulfur Dioxide SO2 Diethyltelluride Te (C2H5) 2 Tungsten Hexafluoride TE	Carbon Monoxide	СО
Hydrogen Sulfide H ₂ S Hydrogen Selenide H ₂ Se Hydrogen Bromide HBr Hydrogen Chloride HCI Helium He Hydrogen Fluoride HF Krypton Kr Nitrogen Oxide N ₂ O Neon Ne Nitrogen Trifluoride NF ₃ Ammonia NH ₃ Nitric Oxide NO Oxygen O ₂ Phosphorous Pentafluoride PF ₅ Sulfer Tetrafluoride SF ₄ Sulfer Hexafluoride Si ₂ H ₆ Silicon Tetrafluoride Si ₄ Silicon Tetrafluoride Si ₄ Silicon Tetrafluoride Si ₄ Silicon Silh ₄ Trichlorosilane Si ₄ Cl ₂ Sulfur Dioxide SO ₂ Diethyltelluride Te (C ₂ H ₅) ₂ Tungsten Hexafluoride Te (C ₂ H ₅) ₂ Tungsten Hexafluoride WF ₆	Carbon Dioxide	CO ₂
Hydrogen Sulfide Hydrogen Selenide Hydrogen Bromide HHBr Hydrogen Chloride Helium He Hydrogen Fluoride Krypton Kr Nitrogen Nitrogen Oxide Neon Ne Nitrogen Trifluoride Nitric Oxide Oxygen Oxygen Oy Phosphorous Pentafluoride PH3 Sulfer Tetrafluoride Silicon Tetrafluoride Silicon Tetrafluoride Silicon Tetrafluoride Silicon Tetrafluoride Silicon Silha Silh	Germane	GeH ₄
Hydrogen Selenide Hydrogen Bromide Hydrogen Chloride Helium He Hydrogen Fluoride Krypton Kr Nitrogen Nıtrogen Nıtrogen Oxide Neon Nitrogen Trifluoride No Nitric Oxide No Oxygen Oxygen Phosphorous Pentafluoride Sulfer Tetrafluoride Silicon Tetrafluoride Silicon Tetrafluoride Silicon Tetrafluoride Silane Silha Si	Hydrogen	H ₂
Hydrogen Bromide Hydrogen Chloride Helium He Hydrogen Fluoride HF Krypton Kr Nitrogen Nıtrogen Neon Ne Nitrogen Trifluoride NF3 Ammonia NH3 Nitric Oxide NO Oxygen Phosphorous Pentafluoride PF5 Phosphine Sulfer Tetrafluoride SF4 Sulfer Hexafluoride Silicon Tetrachloride Silicon Tetrafluoride Silicon Tetrafluoride Silicon Silh4 Trichlorosilane Sulfur Dioxide SO2 Diethyltelluride SO2 Diethyltelluride Tre (C2H5) 2 Tungsten Hexafluoride WF6	Hydrogen Sulfide	H ₂ S
Hydrogen Chloride Helium He Hydrogen Fluoride Krypton Kr Nitrogen Nıtrogen Neon Neon Nitrogen Trifluoride NF3 Ammonia Nitric Oxide No Oxygen Oxygen Oy Phosphorous Pentafluoride PF5 Phosphine Sulfer Tetrafluoride SF4 Sulfer Hexafluoride Silicon Tetrachloride Silicon Tetrafluoride Silicon Tetrafluoride Silicon Silha Silha Trichlorosilane Silha Sulfur Dioxide SO2 Diethyltelluride Tungsten Hexafluoride Ter (C2Hs) 2 Tungsten Hexafluoride WF6	Hydrogen Selenide	H ₂ Se
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Hydrogen Fluoride Krypton Kr Nitrogen Nitrogen Oxide Neon Ne Nitrogen Trifluoride NF3 Ammonia Nitric Oxide Oxygen Phosphorous Pentafluoride PF5 Phosphine Sulfer Tetrafluoride SF4 Sulfer Hexafluoride Silicon Tetrachloride Silicon Tetrafluoride Silicon Tetrafluoride Silicon Tetrafluoride Silicon Silicon Sil	Hydrogen Chloride	HCI
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Nitrogen Oxide Neon Ne Nitrogen Trifluoride NH3 Ammonia NH3 Nitric Oxide NO Oxygen O2 Phosphorous Pentafluoride PF5 Phosphine PH3 Sulfer Tetrafluoride SF4 Sulfer Hexafluoride Silicon Tetrachloride Silicon Tetrafluoride Silicon Tetrafluoride Silicon Tetrafluoride Silicon Tetrafluoride Silicon Tetrafluoride Silicon Tetrafluoride SiH4 Dichlorosilane SiH4 Trichlorosilane SiH4 Trichlorosilane SiH4 Trichlorosilane SiH4 Trichlorosilane SiHCl3 Sulfur Dioxide SO2 Diethyltelluride Te (C2H5) 2 Tungsten Hexafluoride WF6	Krypton	Kr
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Phosphine PH3 Sulfer Tetrafluoride SF4 Sulfer Hexafluoride SF6 Disilane Si2H6 Silicon Tetrachloride SiCl4 Silicon Tetrafluoride SiF4 Dichlorosilane SiH2Cl2 Silane SiH4 Trichlorosilane SiHCl3 Sulfur Dioxide SO2 Diethyltelluride Te (C2H5) 2 Tungsten Hexafluoride WF6	Oxygen	O ₂
Sulfer Tetrafluoride SF4 Sulfer Hexafluoride SF6 Disilane Si2H6 Silicon Tetrachloride SiCl4 Silicon Tetrafluoride SiF4 Dichlorosilane SiH2Cl2 Silane SiH4 Trichlorosilane SiHCl3 Sulfur Dioxide SO2 Diethyltelluride Te (C2H5) 2 Tungsten Hexafluoride WF6	Phosphorous Pentafluoride	PF ₅
Sulfer Hexafluoride SF6 Disilane Si2H6 Silicon Tetrachloride SiCl4 Silicon Tetrafluoride SiF4 Dichlorosilane SiH2Cl2 Silane SiH4 Trichlorosilane SiHCl3 Sulfur Dioxide SO2 Diethyltelluride Te (C2H5) 2 Tungsten Hexafluoride WF6	Phosphine	PH₃
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Silicon Tetrachloride SiCl4 Silicon Tetrafluoride SiF4 Dichlorosilane SiH2Cl2 Silane SiH4 Trichlorosilane SiHCl3 Sulfur Dioxide SO2 Diethyltelluride Te (C2H5) 2 Tungsten Hexafluoride WF6	Sulfer Hexafluoride	SF ₆
Silicon Tetrafluoride SiF4 Dichlorosilane SiH2Cl2 Silane SiH4 Trichlorosilane SiHCl3 Sulfur Dioxide SO2 Diethyltelluride Te (C2H5) 2 Tungsten Hexafluoride WF6	Disilane	Si ₂ H ₆
Dichlorosilane SiH2Cl2 Silane SiH4 Trichlorosilane SiHCl3 Sulfur Dioxide SO2 Diethyltelluride Te (C2H5) 2 Tungsten Hexafluoride WF6	Silicon Tetrachloride	SiCl ₄
Silane SiH4 Trichlorosilane SiHCl3 Sulfur Dioxide SO2 Diethyltelluride Te (C2H5) 2 Tungsten Hexafluoride WF6	Silicon Tetrafluoride	SiF ₄
Trichlorosilane SiHCl ₃ Sulfur Dioxide SO ₂ Diethyltelluride Te (C ₂ H ₅) ₂ Tungsten Hexafluoride WF ₆	Dichlorosilane	SiH ₂ Cl ₂
Sulfur Dioxide SO2 Diethyltelluride Te (C2Hs) 2 Tungsten Hexafluoride WF6	Silane	SiH ₄
Diethyltelluride Te (C2H5) 2 Tungsten Hexafluoride WF6	Trichlorosilane	SiHCl₃
Tungsten Hexafluoride WF6	Sulfur Dioxide	SO ₂
	Diethyltelluride	Te (C ₂ H ₅) ₂
Xenon Xe	Tungsten Hexafluoride	WF ₆
	Xenon	Xe

· This applicable fluid is a reference guide and does not apply to product guarantee.

A Caution

Since the product specified here is used under various operating conditions, its compatibility with fluid and specific equipment must be decided by the person who designs the equipment or decided its specifications based on necessary analysis and test results. The expected performance and safety assurance of the equipment will be the responsibility of the person who has determined its compatibility with the product regardless of any recommendation.

Proper installation, operation and maintenance are also required to assure safe, trouble free performance.



[·] Please consult SMC for a specific recommendation beyond the scope of this document.

Diaphragm Valve for Ultra High Purity

Air operated type

AZ3542 & 4542 Series

- Suitable for UHP gas supply line
- Body material: 316L SS
- Pneumatically actuated normally closed



(Outlet) AZ 3 542 S 2P Size Seat material Code Cv Code Material 0.29 3 PCTFE (Standard) No code vs Polyimide Model 4 Connections Status Maximum operating pressure Size AZ3 AZ4 Normally closed 125 psig Connections Port 2P 2PW 2P 2PW (N.C.) (0.9 MPa) MV4 1/4 inch face seal (Male) 0 Material • FV4 1/4 inch face seal (Female) 0 Code Body material TW4 1/4 inch tube weld 316L SS MV6 3/8 inch face seal (Male) *1) 0 FV₆ 3/8 inch face seal (Female) Ports • TW6 3/8 inch tube weld Code **Ports** Connection TW8 1/2 inch tube weld

> Welded Optional portings and porting configurations available. Please refer to page 808.

2 ports

Machined

2P

2PW

Only available with the same type fittings inlet and outlet.

- O: Inlet and outlet available with any combination of fitting type and size.
- * 1) Fixed fitting (no rotating nut)

Specifications

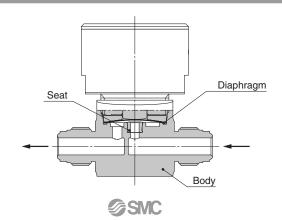
542

Operati	ng Parameters	AZ3542	AZ4542	
Status		Normally closed (N.C.)		
Gas		Select compatible materials	of construction for the gas	
Operating p	ressure	Vacuum to 125	psig (0.9 MPa)	
Proof press	ure	1.5 times the maximu	m operating pressure	
Burst press	ure	3 times the maximur	n operating pressure	
Ambient and	operating temperature	-10 to 71°C ((No freezing)	
Cv		0.29 0.5		
Leak rate	Inboard leakage	2 x 10 ⁻¹¹ Pa·m ³ /s		
Leak rate	Outboard leakage	2 x 10 ⁻¹⁰ Pa·m ³ /s *1)		
Across the	seat leak	1 x 10 ⁻¹⁰ Pa·m ³ /s		
Surface finis	sh	Ra 10μin. (0.25 μm)		
Connection	s	Face seal, Tube weld		
Actuation p	ressure	60 to 110 psig (0.4 to 0.76 MPa)		
Actuation p	ort connection	M5 >	x 0.8	
Actuation port location		Тор		
Installation		Bottom mount		
Internal volume		0.06 in ³ (1.07 cm ³)		
Weight		0.24 kg * ²⁾		
1) Tested with Helium gas inlet pressure 125 psig (0.9 MPa).				

Wetted Parts Material

Wetted Parts	S	
Body	316L SS	
Surface finish	Electropolish + Passivation	
Diaphragm	Ni-Co Alloy	
Seat	PCTFE (Option: Polyimide)	

Construction



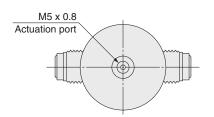
^{* 2)} Weight for AZ3542S2PMV4MV4 including individual boxed weight. It may vary depending on connections or options.

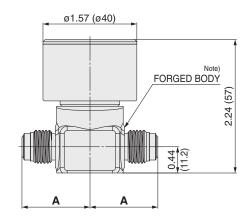
Diaphragm Valve for Ultra High Purity Air operated type AZ3542 & 4542 Series

Dimensions inch (mm)

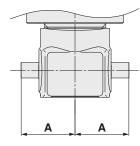
AZ3542 & 4542

Ports: 2P (Machined)

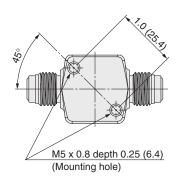




Connections: MV□



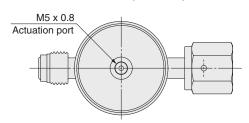
Connections: TW□

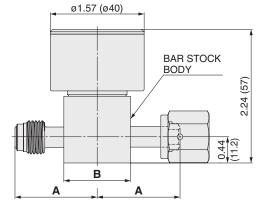


Note) MV6 is bar stock body.

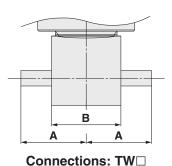
Ports	Connections	Α		
FULS	Connections	inch	(mm)	
	MV4	1.14	(29.0)	
2P	TW4	0.875	(22.2)	
(Machined)	MV6	1.5	(38.1)	
(Macrimeu)	TW6	0.875	(22.2)	
	TW8	1.125	(28.6)	

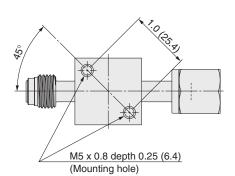
Ports: 2PW (Welded)





Connections: $MV \square$, $FV \square$





Ports	Connections	Α		В	
Forts	Connections	inch	(mm)	inch	(mm)
	MV4	1.39	(35.3)		
	FV4	1.39	(33.3)		
2PW	TW4	1.06	(26.9)	1 10 00	(00.4)
(Welded)	MV6	1.93		1.12 sq.	(28.4)
	FV6	1.93	(49.0)		
	TW6	1.325	(33.7)		



AP

SL

AK

BP

Diaphragm Valve for Ultra High Purity

Manually operated

RoHS

AZ3652 & 4652 Series

Size

Cv

0.29

0.5

Suitable for UHP gas supply line

Code

3

Knob

1/4 turn indicating round knob

with a raised rectangular section

Body material: 316L SS



How to Order (Inlet) (Outlet) AZ 3 652 S 2P Seat material Code Material PCTFE (Standard) No code Polyimide

Model Maximum operating pressure 250 psig

Material • Code Body material 316L SS

(1.7 MPa)

		Ports
Code	Ports	Connection
2P	2 norte	Machined
2PW	2 ports	MahlaM

Optional portings and porting configurations available. Please refer to page 808.

Connections

Code	Connections	Size	AZ3		AZ4	
Code	Connections	Port	2P	2PW	2P	2PW
MV4	1/4 inch face seal (Male)	*1)		0		0
FV4	1/4 inch face seal (Fema	1/4 inch face seal (Female)				0
TW4	1/4 inch tube weld	1/4 inch tube weld				
MV6	3/8 inch face seal (Male)	3/8 inch face seal (Male) *1)				0
FV6	3/8 inch face seal (Fema	3/8 inch face seal (Female)				0
TW6	3/8 inch tube weld			•	0	
TW8	1/2 inch tube weld					

- Only available with the same type fittings inlet and outlet.
- O: Inlet and outlet available with any combination of fitting type and size.
- * 1) Fixed fitting (no rotating nut)

Specifications

Code

652

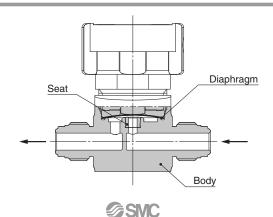
Operati	ing Parameters	AZ3652	AZ4652	
Gas		Select compatible materials of construction for the gas		
Operating p	ressure	Vacuum to 250	psig (1.7 MPa)	
Proof press	ure	1.5 times the maximu	m operating pressure	
Burst press	ure	3 times the maximur	n operating pressure	
Ambient and	operating temperature	-40 to 71 °C	(No freezing)	
Cv		0.29 0.5		
Leak rate	Inboard leakage	2 x 10 ⁻¹¹ Pa·m ³ /s		
Leak rate	Outboard leakage	2 x 10 ⁻¹⁰ Pa·m ³ /s *1)		
Across the	seat leak	1 x 10 ⁻¹⁰ Pa·m ³ /s		
Surface fini	sh	Ra 10 μin.(0.25 μm)		
Connection	S	Face seal,	Tube weld	
Installation		Bottom mount		
Internal volume		0.06 in ³ (1.07 cm ³)		
Weight		0.22 kg * ²⁾		
Knob		1/4 turn indicating round knob with a raised rectangular section		
* 1) Tested wi	1) Tested with Helium gas inlet pressure 250 psig (1.7 MPa).			

Wetted Parts Material

	Wetted Parts	S
	Body	316L SS
	Surface finish	Electropolish + Passivation
	Diaphragm	Ni-Co Alloy
	Seat	PCTFE (Option: Polyimide)

- * 2) Weight for AZ3652S2PMV4MV4 including individual boxed weight. It may vary depending on connections.

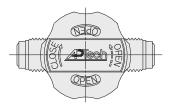
Construction

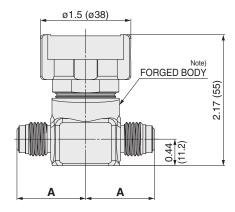


Dimensions inch (mm)

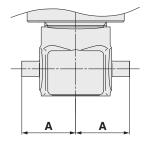
AZ3652 & 4652

Ports: 2P (Machined)

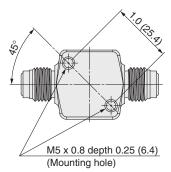




Connections: MV□



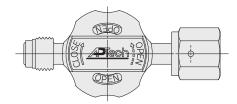
Connections: TW□

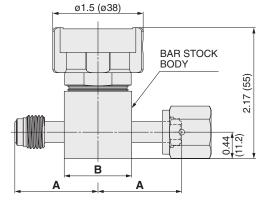


Note) MV6 is bar stock body.

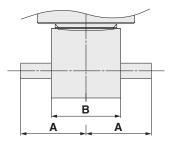
Ports	Connections	Α						
		inch	(mm)					
2P (Machined)	MV4	1.14	(29.0)					
	TW4	0.875	(22.2)					
	MV6	1.5	(38.1)					
	TW6	0.875	(22.2)					
	TW8	1.125	(28.6)					

Ports: 2PW (Welded)

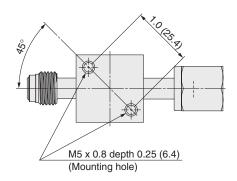




Connections: MV□, FV□



Connections: TW□



Dorto	Commontions	Α		В	
Ports	Connections	inch	(mm)	inch	(mm)
	MV4	1.39	(35.3)	-1.12 sq.	(28.4)
	FV4	1.39			
2PW	TW4	1.06	(26.9)		
(Welded)	MV6	1.93	(49.0)		
, ,	FV6	1.93			
	TW6	1.325	(33.7)		



Optional knob color available. Red, blue, green, gold, silver, purple, etc. Please contact SMC for further information.

AP

SL

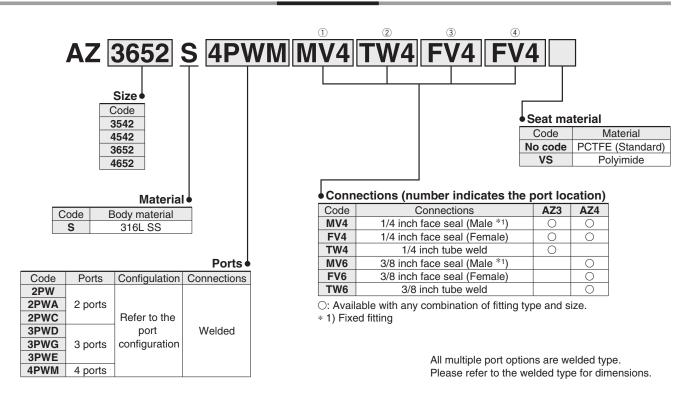
ΑZ

AK

BP

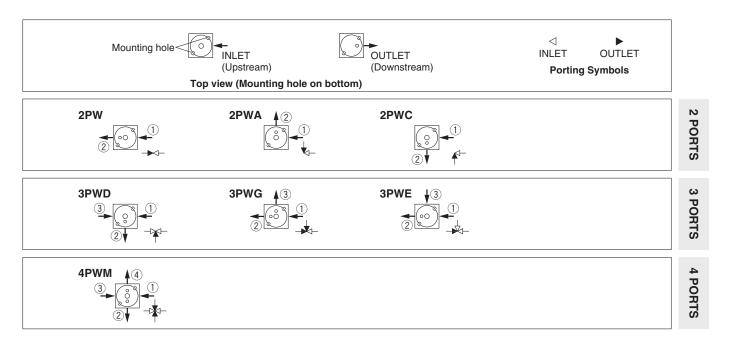
AZ Series / Diaphragm Valve Optional Porting Configuration

How to Order



Port Configuration

- · Valves are illustrated top view looking down through the valve.
- · Inlet (Upstream) is defined as a port connected to the region below the valve seat. It is illustrated with an arrow pointing towards the valve body or an "empty" triangle on the schematic. Outlet (Downstream) is defined as a port connected to the region above the seat and below the diaphragm. It is illustrated with an arrow pointing away from the valve body or a "filled" triangle on the schematic.
- The traditional flow direction is INLET to OUTLET, but AP Tech valves may be employed in either flow direction
- · End connections are specified in numerical order per the diagram's numbered arrows.







Process Gas Equipment / Diaphragm Valve Specific Product Precautions

Be sure to read this before handling the products. Refer to back page 50 for Safety Instructions and pages 633 and 634 for Process Gas Equipment Precautions.

Selection

∧ Warning

1. Confirm the specifications.

This product is used in gas delivery systems to shutoff gas flow. When selecting the product, confirm the operating conditions, such as type of gas, operating pressure (inlet and outlet), flow rate, actuating pressure, operating temperature etc., and use within the operating range specified in the catalog. The product may not be suitable for use with specific gases and applications/environments. Check the compatibility of the product materials with the process gas.

Design the equipment and select the product by understanding the characteristics of gas.

Mounting

⚠ Warning

- Confirm the mounting direction of the product.
 Inlet ports are labeled with an "IN" mark. The outlet ports are usually not labeled but may be labeled with an "OUT" mark.
 Orient the valve as specified by the system designer.
- Connect actuation pressure to the valve actuator connection. (Air operated type)
 Use nitrogen or clean dry air for actuation pressure. The connection M5 thread.
- 3. After installation, check internal leakage (leakage across seat) with inert gases.

Perform a helium leak test depending on applications.

Maintenance

⚠ Warning

1. If a valve requires repair, contact SMC or sales representative.

Operation (Air operate type)

Marning

- 1. Use nitrogen or clean dry air as actuation pressure.
- 2. Confirm the valve type (N.C.).

In the case of N.C. (Normally Closed), valve will open when applying actuation pressure to the valve actuator connection and valve will close when actuation pressure is vented to atmospheric pressure.

3. Apply actuation pressure within the range of specifications.

Operation (Manually operated type)

Marning

1. When closing the valve, rotate the handle clockwise until it completely stops.

There is the internal stop in the handle or in the valve body. Rotate the handle clockwise until the internal stop is reached and it completely stops.

2. When opening the valve, rotate the handle counterclockwise until it completely stops.

There is the internal stop in the handle. Rotate the handle counterclockwise until the internal stop is reached and it completely stops.

3. Do not use a tool when rotating the handle.

When the handle is rotated with a tool, it may apply excessive torque to the handle or inside the valve body and it may cause damage. Rotate the handle by hand.

AP

SL

AZ

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BP